

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hidemasa KAI**

Art Unit: **1792**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR  
STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.116**  
**EXPEDITED PROCESSING REQUESTED**

**Mail Stop: AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**December 22, 2009**

Sir:

This paper is filed (along with a petition for a one-month extension of time) in response to the Office Action dated August 20, 2009. The PTO was closed on December 20 (Sunday) and 21 (USPTO closed due to inclement weather).

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.